

## PATENT ATTORNEY DOCKET NO. 053848-5018

#### IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: Yoshijiro USHIO, et al.

Application No.: 10/774,623

Confirmation No.: 1365

Filed: February 10, 2004

Group Art Unit: 3723

Allowed: June 19, 2006

Examiner: Jacob K. Ackun

For: METHOD AND DEVICE FOR STIMULATION, METHOD AND DEVICE FOR POLISHING, METHOD AND DEVICE FOR PREPARING CONTROL PARAMETERS OR CONTROL PROGRAM, POLISHING SYSTEM, RECORDING MEDIUM, AND METHOD OF MANUFACTURING SEMICONDUCTOR DEVICE

Commissioner for Patents Alexandria, VA 22314

Sir:

### REQUEST FOR PRIORITY ACKNOWLEDGEMENT

A copy of the Certified Priority Document for the above-identified application was filed in the U.S. Patent and Trademark Office on February 10, 2004. To date, no priority acknowledgement has been received. A copy of the Certified Priority Document along with a copy of postcard receipt submitted February 10, 2004 is attached.

Please promptly send the priority acknowledgement. Thank you.

Respectfully submitted,

MORGAN, LEWIS & BOCKIUS LLP

Bv:

Robert J. Goodell Reg. No. 41,040

Dated: July 31, 2006

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PLEASE STAMP AND RETURN TO SHOW RECEIPT OF:

New U.S. Patent Application of: Yoshijiro USHIO et al.

For: METHOD AND DEVICE FOR SIMULATION, METHOD AND DEVICE FOR POLISHING, METHOD AND DEVICE FOR PREPARING CONTROL PARAMETER OR CONTROL PROGRAM, POLISHING SYSTEM, RECORDING MEDIUM, AND METHOD OF MANUFACTURING SEMICONDUCTOR DEVICE

# ATTENTION: MAIL STOP PATENT APPLICATION

- 1. Please charge Deposit Account No. 50-0310 in the amount of \$1568.00 2. Transmittal Letter
- 3. Specification of 98 pages, 7 independent claims and 43 total claims
- 4. Published WO 03/030233 A1 (Cover pages only)
- 5. Drawings 14 sheets 15 total figures
- 6. Declaration and Power of Attorney
- 7. Recordation Form Cover Sheet
- 8. Assignment
- 9. Information Disclosure Statement
- 10. International Search Report
- 11. PTO-1449, 7 references as listed
- ₰2. Certified copy of Japanese Application No. 2001-251421 filed

Dated: February 10, 2004

Attorney Docket No.: 053848-5018

RG2/lmp

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Alycia Johnson

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## 日本国特許庁 JAPAN PATENT OFFICE

別紙添付の書類に記載されている事項は下記の出願書類に記載されている事項と同一であることを証明する。

This is to certify that the annexed is a true copy of the following application as filed vith this Office.

出願年月日 Date of Application:

2001年 8月22日

出 願 番 号 Application Number:

特願2001-251421

[ST. 10/C]:

 $[\ J\ P\ 2\ 0\ 0\ 1\ -\ 2\ 5\ 1\ 4\ 2\ 1\ ]$ 

射 願 人 pplicant(s):

株式会社ニコン

特許庁長官 Commissioner, Japan Patent Office 2003年11月 5日

今 井 康 <del>門</del>